

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Masayoshi SHIMIZU

Serial No. 09/957,032

Group Art Unit: 2624

Confirmation No. 4255

Filed: September 21, 2001

Examiner: Wesley J. Tucker

For: IMAGE STATUS ESTIMATING METHOD, IMAGE CORRECTING METHOD, IMAGE  
CORRECTION APPARATUS, AND STORAGE MEDIUM

**LETTER TO EXAMINER REQUESTING INTERVIEW**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

An Amendment has been concurrently filed with this Letter.

The undersigned would like to schedule a personal Interview with the Examiner in this case before the next Action is issued to discuss the Amendment and the prior art.

The Examiner is respectfully requested to contact the undersigned to suggest a convenient day and time for such an interview.

Respectfully submitted,

STAAS & HALSEY LLP

Date: August 14, 2007

By: /J. Randall Beckers/  
J. Randall Beckers  
Registration No. 30,358

1201 New York Avenue, NW, 7th Floor  
Washington, D.C. 20005  
Telephone: (202) 434-1500  
Facsimile: (202) 434-1501

Serial No. 09/957,032